



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

(Attorney Docket No.: 02955.247(AD-27CN2))

Applicant(s):

MARTIN, et al.

Serial No.:

10/662,895

Filed:

September 15, 2003

For:

PACKAGE FOR SELLING AN INTEGRATED CIRCUIT DIE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

CERTIFICATE UNDER 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being deposited as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date set forth below.

10/20/04

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INFORMATION DISCLOSURE STATEMENT

Applicants and their attorney are aware of the following publications and information listed on the attached PTO Form 1449, and in accordance with 37 CFR §1.97 for the Examiner's consideration.

Pursuant to 37 C.F.R. §1.97, Applicants hereby make of record the documents listed on the attached Form PTO-1449. The references listed on the enclosed Form PTO-1449 with an asterisk (*) have been cited in related applications, U.S. Serial Nos. 09/947,859 (now U.S. Pat. No. 6,621,158) and 08/471,748 (now U.S. Pat. No. 6,323,550). Therefore, pursuant to 37 C.F.R. §1.98(d), no copies of the previously cited art are being enclosed.

This application is a continuation of 09/947,859 (now U.S. Pat. No. 6,621,158), which is a continuation of 08/471,748 (now U.S. Pat. No. 6,323,550).

It is respectfully requested that the information above be expressly considered during the prosecution of this application and that the publications be made of record therein and appear among the "References Cited" on any patent to issue therefrom. In this regard, it is requested that the Examiner initial and return a copy of the enclosed Form PTO-1449 with the next Patent Office Communication.

MARTIN, et al. U.S.S.N. 10/662,895

This submission does not represent that a search has been made and does not constitute an admission that the listed documents are material to patentability or that the listed documents are prior art. If it should be determined that any of the listed documents do not constitute "prior art" under United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such documents.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits and is therefore submitted as both timely and proper; therefore, no fees are believed to be due.

The Commissioner, however, is hereby authorized to charge any fee deficiency or credit any overpayment to Deposit Account No. <u>08-0219</u>. A duplicate copy of this sheet is enclosed for that purpose.

Respectfully submitted,

Date: 10-20-04

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WILMER CUTLER PICKERING HALE AND DORR LLP SUBT. FORM PTO-1449

INFORMATION DISCLOSURE IN AN APPLICATION

DOCKET NUMBER 02955.247

APPLICATION NUMBER 10/662,895

APPLICANT
Martin et al.

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